

**Search Notes**

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Examiner

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Applicant(s)/Patent under  
Reexamination

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Art Unit

1615

**SEARCHED**

Class	Subclass	Date	Examiner

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East	5/24/2006	DY
All databases	5/24/2006	DY